

*Status of the Claims*

The listing of claims will replace all prior versions, and listings of claims in the application.

1. (Original) In a multiple stage, multiple exposure lithography system, a method comprising:

processing a first pair of wafers;  
style="padding-left: 40px;">exchanging the first pair of wafers to pattern each sequentially using a first reticle;  
style="padding-left: 40px;">exchanging the first reticle for a second reticle;  
style="padding-left: 40px;">exchanging the first pair of wafers to pattern each sequentially using the second reticle;  
style="padding-left: 40px;">exchanging the first pair of wafers for a second pair of wafers;  
style="padding-left: 40px;">processing the second pair of wafers;  
style="padding-left: 40px;">exchanging the second pair of wafers to pattern each sequentially using the second reticle;  
style="padding-left: 40px;">exchanging the first and second reticles; and  
style="padding-left: 40px;">exchanging the second pair of wafers to pattern each sequentially using the first reticle.

2-3 (Cancelled)

4. (Original) In a multiple stage, multiple exposure lithography system, a method comprising:

processing a first pair of wafers;  
exchanging the first pair of wafers to pattern each sequentially using a first reticle;  
exchanging the first reticle for a second reticle;  
exchanging the first pair of wafers to pattern each sequentially using the second reticle;  
exchanging a first one of the first pair of wafers for a first one of a second pair of wafers;  
processing the first one of the second pair of wafers;  
exchanging the second reticle for the first reticle;  
exchanging the second one of the first pair of wafers for a second one of the second pair of wafers;  
processing the second one of the second pair of wafers;  
exchanging the second pair of wafers to pattern each sequentially using the first reticle;  
exchanging the first and second reticles; and  
exchanging the second pair of waters to pattern each sequentially with the second reticle.

5. (Cancelled)